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Docket No.: 2328-050

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Jian J. CHEN et al.

U.S. Patent Application No. 09/821,027

Filed: March 30, 2001

: : EXPEDITED PROCEDURE
: : Response under 37 CFR 1.116
: Confirmation No.
5541
:
: Group Art Unit: 1763
:
: Examiner: ANNA M. CROWELLFor: INDUCTIVE PLASMA PROCESSOR HAVING COIL WITH PLURAL WINDINGS
AND METHOD OF CONTROLLING PLASMA DENSITYAMENDMENTMailStop AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

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DATE

571-273-8300

FACSIMILE NUMBER

This paper is submitted in reply to the communication for the Board of Patent Appeals and Interference (Paper No. 0106), mailed January 31, 2006. Applicants respectfully request that the following amendments as to form be entered to place this application in condition for allowance.